



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

January 18, 2026

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG766617530

LABORATORY GROWN DIAMOND

OVAL BRILLIANT

9.26 X 6.38 X 3.97 MM

1.47 CARAT

E

VVS 2

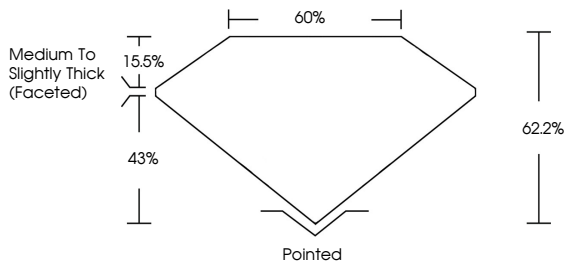
EXCELLENT

EXCELLENT

NONE

 LG766617530

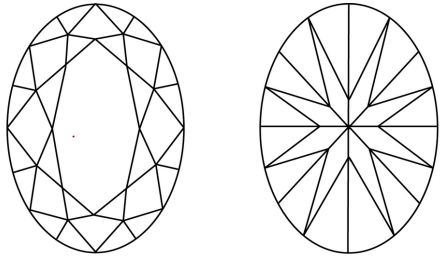
PROPORTIONS



Medium To Slightly Thick (Faceted)

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

D E F G H I J Faint Very Light Light

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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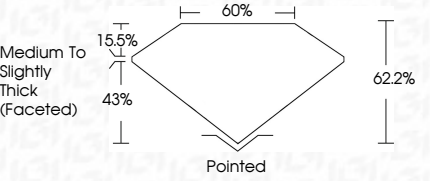
VVS 2

EXCELLENT

EXCELLENT

NONE

 LG766617530



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Pointed



January 18, 2026

IGI Report No LG766617530

OVAL BRILLIANT

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Carat Weight

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Table

Depth

Girdle

Medium to Slightly Thick (Faceted)

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

1.47 CARAT

E

VVS 2

62.2%

60%

Pointed

EXCELLENT

EXCELLENT

NONE

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